## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE PATENT APPLICATION

App./Confirm Nos.: 09/683,985 2597 Atty. Docket: BUR920020014US1 Applicant: Steven Voldman Today's Date: November 16, 2007

Filing Date: March 8, 2002 Examiner: Ori Nadav Title: **A METHOD OF FORMING LOW** Group Art Unit: 2811

**CAPACITANCE ESD ROBUST DIODES** 

## Amendments Under 37 C.F.R 1.114

## Amendment H

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In response to the Final Office Action dated October 4, 2007, Applicant respectfully requests reconsideration of the outstanding rejections and reexamination of the present application in light of the following remarks and amendments.